

Substitute for Form 1449/PTO



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of 2

Complete if Known

Application Number	09/910,583
Filing Date	July 20, 2001
First Named Inventor:	Kevin Mukai
Art Unit	1762
Examiner Name	Not Yet Assigned

Attorney Docket Number 5047 USA/TCG/PMD/LE

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)				
Tam	us-	2002/0000195 A1		01-03-2002	Bang et al.	
	us-	4,557,950		12-10-1985	Foster et al.	
	us-	5,094,984		03-10-1992	Liu et al.	
	us-	5,656,556		08-12-1997	Yang	
	us-	6,030,445		02-29-2000	Gregg et al.	
	us-	6,091,121		07-18-2000	Oda	
	us-	6,099,647		08-08-2000	Yieh et al.	
	us-	6,110,556		08-29-2000	Bang et al.	
	us-	6,117,244		09-12-2000	Bang et al.	
	us-	6,159,870		12-12-2000	Chakravarti et al.	
Tam	us-	6,177,344 B1		01-23-2001	Xia et al.	
	us-					
	us-					
	us-					
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁸
		Country Code ³	Number ⁴ Kind Code ⁵ (if known)				
Tam		EP	0 843 348 A2 /	05-20-1998	Applied Materials, Inc.		

Examiner Signature		Date Considered	3/16/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached.

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Substitute for Form 1449/PTO		Complaint if Known Application Number 09/910,583 Filing Date July 20, 2001 First Named Inventor: Kevin Mukai Art Unit 1762 Examiner Name Not Yet Assigned Attorney Docket Number 5047 USA/TCG/PMD/LE			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					
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Sheet	2 of 2				
NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	No.			Indicate name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
Tbm		KERN, WERNER, ET AL., Simultaneous deposition and fusion flow planarization of borophosphosilicate glass in a new chemical vapor deposition reactor, Thin Solid Films, Elsevier-Sequoia S.A., Lausanne, CH, Vol. 206, No. 1/2, December 10, 1991, pages 64-69, XP000355313, ISSN: 0040-6090.			
Tbm		ROBLES, STUARDO, ET AL., Gap Fill and Film Reflow Capability of Subatmospheric Chemical Vapor Deposited Borophosphosilicate Glass, Reprinted from Journal Of The Electrochemical Society, Vol. 143, No. 4, April 1996, ©1995, pgs. 1414-1421.			
Tbm		XIA, L.-Q, ET AL., Process Characteristics for Subatmospheric Chemical Vapor Deposited Borophosphosilicate Glass and Effect of Carrier Gas, Reprinted from Journal Of The Electrochemical Society, Vol. 144, No. 9, September 1997, © 1997, pgs. 3208-3212.			
Tbm		XIA, L.-Q., ET AL., High Aspect Ratio Trench Filling Using Two-Step Subatmospheric Chemical Vapor Deposited Borophosphosilicate Glass for <0.18 µm Device Application, Journal of The Electrochemical Society, Manchester, New Hampshire, U.S.A., Vol. 146, No. 5, May 1999, pages 1884-1888, XP001002961, ISSN: 0013-4651			
Tbm		Search Report for PCT/US 02/22608, mailed November 7, 2002, 4 pages.			
Tbm		Search Report for PCT/US 02/23520, mailed November 25, 2002, 5 pages.			

Examiner Signature	Date Considered	3/16/04
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